



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:) Docket No: LAM2P266
John E. LANG)
Application No: 09/274,194) Group Art Unit: 1765
Filed: October 16, 2001) Examiner: M. Song
For: METHOD OF REMOVING PHOTORESIST)
MATERIAL WITH DYMETHYL)
SULFOXIDE)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail addressed to: Commissioner for Patents, P.O. Box 1450, Attn: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on March 1, 2004.

Signed:

Courtney F. Yacregar

Mail Stop: RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

This is in response to the Final Office Action mailed on September 30, 2003 and the Advisory Action mailed on February 17, 2004. The period of respond extends to March 1, 2004, with a two-month extension of time. Please enter the following amendments and remarks in the above-identified patent application:

Amendments to the claims are reflected in the Listing of Claims which beings on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

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